

Band alignment at $\beta\text{-Ga}_2\text{O}_3/\text{III-N}$ (III=Al, Ga) interfaces through hybrid functional calculations

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The band alignment and the chemical bonding at the $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ interfaces are studied through hybrid functional calculations. We construct realistic slab models with III-O (III=Al, Ga) bonds dominating the chemical bonding at both interfaces. The epitaxial relationships between $\beta\text{-Ga}_2\text{O}_3$ and wurtzite AlN and GaN determined from experiments are adopted in our slab models. These models satisfy electron counting rules and all the dangling bonds are saturated at the interfaces. $\beta\text{-Ga}_2\text{O}_3$ is found to form type II heterojunctions with both wurtzite AlN and GaN. For the interfaces with AlN and GaN substrates, the calculated valence band offsets are 0.74 and 0.90 eV, respectively. These are in good agreement with experimental values. The obtained band alignments are useful for designing optical and electronic devices based on $\beta\text{-Ga}_2\text{O}_3$ and group III nitrides.

$\beta\text{-Ga}_2\text{O}_3$ has attracted a great deal of attention because of its promising applications particularly in high-power electronics.^{1,2} This material has a remarkable high breakdown electric field exceeding that of the widely used SiC and GaN.^{1,2} Its wide band gap of 4.5-4.9 eV makes it also suitable for fabricating solar-blind ultraviolet (UV) photodetectors.^{3,4} Most importantly, single-crystal wafers can be obtained at low cost from the melt.⁵ Moreover, the possibility of alloying this oxide with Al_2O_3 to form $\beta\text{-(Al}_x\text{Ga}_{1-x})_2\text{O}_3$ ^{6,7} provides high flexibility for band gap engineering and device design. Group-III nitrides have been intensively studied because of their wide applications in optoelectronic and power devices.⁸ The advantages of using III-N and their alloys are their tunable band gaps and chemical stability. The in-plane lattice mismatch between the (201) plane of $\beta\text{-Ga}_2\text{O}_3$ and (0001) plane of wurtzite AlN and GaN is small so that high-quality epitaxial growth can be easily achieved,⁹ which is helpful to minimize interfacial defects. The (0001) plane cut for III-N leads to polar interfaces between $\beta\text{-Ga}_2\text{O}_3$ and III-N. Recently, the heterojunctions between $\beta\text{-Ga}_2\text{O}_3$ and GaN or AlN have been experimentally studied by several groups.⁹⁻¹³ These heterojunctions are expected to be used in ultraviolet photodetectors in which $\beta\text{-Ga}_2\text{O}_3$ is fabricated as window material of UV light in view of its large band gap and high thermal and chemical stability.¹² In addition, bipolar devices based on these heterojunctions are appealing because efficient p-type AlN or GaN and n-type Ga_2O_3 have already been achieved.¹⁴ The construction of bipolar devices overcomes the problem of efficiently p-doping $\beta\text{-Ga}_2\text{O}_3$, which currently limits the potential of this material.¹⁵

Band offsets are key parameters in heterojunction device designs because they determine the transport properties. For the interfaces between $\beta\text{-Ga}_2\text{O}_3$ and wurtzite AlN or GaN, the reported band alignment can vary by as much as 1 eV.⁹⁻¹² Such an ambiguity also holds for

some other dielectric materials deposited on $\beta\text{-Ga}_2\text{O}_3$.¹⁶ Therefore, computational investigations are necessary to accurately determine the intrinsic band offsets of these interfaces.

In this work, we study the interface between $\beta\text{-Ga}_2\text{O}_3$ and III-N through first-principles calculations. We employ state-of-the-art hybrid functionals to overcome the band gap problem of density functional theory (DFT). The accuracy of hybrid functionals in the calculation of band offsets has already been demonstrated and found to be on the order of ~ 0.2 eV,¹⁷⁻²⁴ conferring significant predictive capabilities to this method. The band offsets are derived by applying an alignment scheme in which interface calculations and bulk calculations of the interface components are combined. In the polar interface calculations, the in-plane strains due to the mismatch and the built-in electric fields due to the nonvanishing macroscopic polarization are also taken into account. We obtain valence band offsets (VBOs) of 0.74 and 0.90 eV for $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ interfaces, respectively.

The geometry optimization and electronic structure calculations are performed with the CP2K package.²⁵ Within the Gaussian Plane Waves (GPW) method, the DFT Kohn-Sham equations²⁶ are efficiently solved in a Gaussian-type basis set, while the electron density is expanded using an auxiliary plane-wave (PW) basis set. We use double- ξ MOLOPT basis sets.²⁷ The valence-core interactions are described by Goedecker-Teter-Hutter (GTH)²⁸ pseudopotentials. For Ga, the $3d$ states are treated as valence states.²⁹ For the geometry optimizations, we use the semilocal generalized gradient approximation (GGA) proposed by Perdew-Burke-Ernzerhof (PBE).³⁰ For the electronic structure calculations of the bulk components, i.e., $\beta\text{-Ga}_2\text{O}_3$, AlN and GaN, we use PBE0(α) hybrid functionals^{31,32} in which the fractions α of Fock exchange are adjusted to reproduce the experimental band gaps. It has been demonstrated that Koopmans' condition is closely satisfied for such hybrid functionals.³³ The PW energy cutoff is set to 600 Ry and only the Γ point is sampled in the Brillouin zone as the

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supercells are sufficiently large to ensure convergence. In the PBE0(α) calculations, an auxiliary basis set for the auxiliary density matrix method is employed to speed up the Fock exchange calculations.³⁴

We determine the band alignment at the interface by using the method developed in Refs. 35 and 36, which is compatible with the presence of built-in electric fields. The VBO of a heterojunction A/B is expressed as

$$\text{VBO}(A/B) = (E_{\text{VBM}}^B - \bar{V}^B) - (E_{\text{VBM}}^A - \bar{V}^A) + (\bar{V}^B - \bar{V}^A) \quad (1)$$

where $E_{\text{VBM}} - \bar{V}$ is the energy difference between the valence band maximum (VBM) and the local reference level obtained in two separate bulk calculations for interface components A and B , and $\bar{V}^B - \bar{V}^A$ is the interface lineup term obtained in the interface calculation. The interface lineup is obtained at the PBE0(α) level in which α is the average of the exchange mixing parameters pertaining to the two interface components.^{17,19,23,37} The average electrostatic potential is chosen as the local reference level. The conduction band offset (CBO) between A and B can then be derived by using the band gap E_g of each interface component:

$$\text{CBO}(A/B) = (E_g^B - E_g^A) + \text{VBO}(A/B). \quad (2)$$

Since the interface is perpendicular to the polar (0001) axis of wurtzite AlN or GaN, the macroscopic polarization in the nitride layers induces finite electric fields in the bulk components.³⁸ To deal with the finite bulk electric fields, we adopt the scheme proposed by Foster *et al.*³⁹ We first apply a double convolution⁴⁰ over the planar average of the electrostatic potential $V(z)$ along the direction z , which is orthogonal to the interface plane. Then, we take the nominal interface position at the midway between the atomic planes that form the interface.³⁹ By extrapolating the macroscopically averaged electrostatic potential from each bulklike region to the nominal interface position, the interface lineup can be determined in a way that eliminates the effects of the electric fields.³⁹ The uncertainty in the interface lineup produced by the extrapolation procedure can be expressed as $|E_1 - E_2|\delta_z$,³⁹ where E_1 and E_2 are the electric fields in the bulklike regions of the two interface component and δ_z is the uncertainty in the determination of the interface position. By setting δ_z to 25% of the atomic layer distance, we obtain a rough estimate of the errors involved in the potential lineups, which are found not to exceed 0.06 and 0.01 eV at $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ interfaces, respectively.

$\beta\text{-Ga}_2\text{O}_3$ shows a monoclinic crystal structure and has two types of coordinations for Ga^{3+} ions, pertaining to either distorted tetrahedra or distorted octahedra.^{2,41} To determine the optimal fraction of Fock exchange to be used for $\beta\text{-Ga}_2\text{O}_3$, we used the experimental structure derived in Ref. 41 (see Table I). For bulk AlN and GaN, we perform full relaxations with the PBE functional. The obtained lattice parameters are given in Table I together

TABLE I. Lattice parameters, band gaps (in eV) and VBM positions (in eV) relative to the bulk averaged electrostatic potential of $\beta\text{-Ga}_2\text{O}_3$, AlN, and GaN obtained at the PBE0(α) level. The lattice parameters of $\beta\text{-Ga}_2\text{O}_3$ are experimental values taken from Ref. 41 and correspond to the conventional unit cell.⁴² The exchange mixing parameters α , which reproduce the experimental band gaps for each material, are also given.

	a (Å)	b (Å)	c (Å)	β	α	E_g	VBM
$\beta\text{-Ga}_2\text{O}_3$	12.23	3.04	5.80	103.70°	0.27	4.87	2.99
	a (Å)	c (Å)	u	α	E_g	VBM	
AlN	3.14	4.98	0.384	0.25	6.07	4.73	
Expt. ⁴³	3.11	4.98	0.382				
GaN	3.24	5.24	0.377	0.27	3.37	4.46	
Expt. ⁴³	3.19	5.19	0.377				

TABLE II. Lattice parameters, band gaps (in eV), and VBM positions (in eV) relative to the bulk averaged electrostatic potential of strained $\beta\text{-Ga}_2\text{O}_3$ corresponding to different substrates.

strained	substrate	a' (Å)	b (Å)	c (Å)	β'	E_g	VBM
$\beta\text{-Ga}_2\text{O}_3$	AlN	14.48	3.14	6.08	52.2°	4.38	2.70
$\beta\text{-Ga}_2\text{O}_3$	GaN	14.94	3.24	6.08	50.5°	4.13	2.23

with the corresponding experimental values. The band gaps and VBM positions relative to the bulk averaged electrostatic potential of bulk $\beta\text{-Ga}_2\text{O}_3$, AlN, and GaN are obtained at the PBE0(α) level.

In experimental studies, the interfaces with $\beta\text{-Ga}_2\text{O}_3$ are usually grown by taking AlN or GaN as substrates.^{9,11,12} In these lattice-mismatched cases, the substrate determines the in-plane lattice constants.⁴⁴ The biaxial strain caused by the lattice mismatch makes the $\beta\text{-Ga}_2\text{O}_3$ epilayer adopt a new interplane lattice constant. To model the $\beta\text{-Ga}_2\text{O}_3/\text{III-N}$ (III=Al,Ga) interfaces, we follow the epitaxial relationships of $\beta\text{-Ga}_2\text{O}_3$ ($\bar{2}01$) \parallel AlN (0001) and $\beta\text{-Ga}_2\text{O}_3$ [102] \parallel AlN $[\bar{1}100]$, which have been determined experimentally.⁹ The same epitaxial relationships are also applied to the GaN case. In order to minimize the interfacial lattice mismatch, we construct an orthorhombic 510-atom supercell containing a III-N (0001) slab with (8×2) in-plane periodicity and a $\beta\text{-Ga}_2\text{O}_3$ ($\bar{2}01$) slab with (3×2) in-plane periodicity (cf. Figs. 1 and 2). The x and y axes correspond to the [102] and [010] crystal axes of $\beta\text{-Ga}_2\text{O}_3$, respectively. For AlN, this yields in-plane lattice mismatches of -1.4% and 3.0% along the x and y axes, respectively. In the case of GaN, the respective mismatches are 1.7% and 6.0% . In this way, $\beta\text{-Ga}_2\text{O}_3$ is strained and lattice matched to AlN or GaN in the same way as in the experiments.^{9,11,12} The z -axis coincides with the AlN [0001] direction, while the x and y axes are parallel to the $[\bar{1}100]$ and $[11\bar{2}0]$ directions of AlN, respectively. Since the x and y axes also match the [102] and [010] directions of $\beta\text{-Ga}_2\text{O}_3$, the

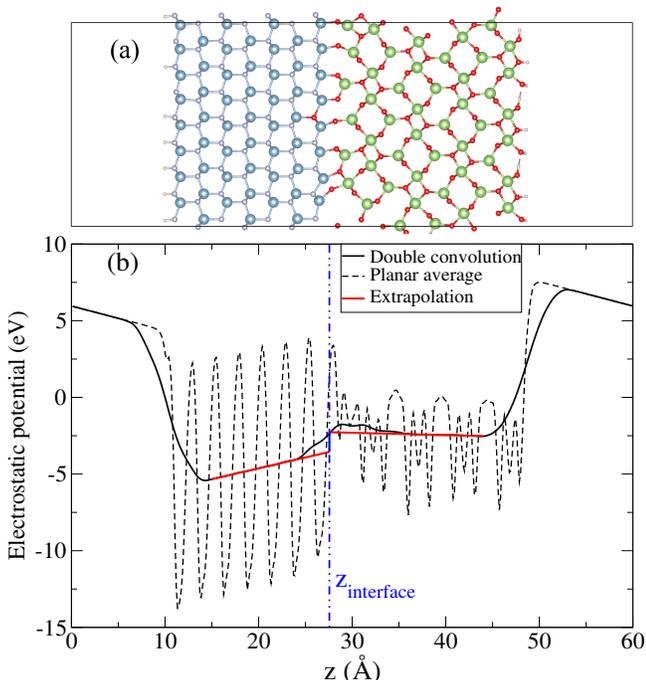


FIG. 1. (a) Atomistic model of the relaxed β -Ga₂O₃/AlN interface obtained at the PBE level and (b) its planar and macroscopically averaged electrostatic potential obtained at the PBE0(α) level. The interface lineup is determined to be 1.29 eV.

periodicities are maintained along these two orthogonal directions in the interface supercell model. At the interface, III-O bonds are used to bridge the oxide slab to the AlN or GaN slab. III-O bonds are expected to be more stable than Ga-N bonds because of the higher electronegativity difference. Some interfacial O atoms are twofold coordinated and thus show a different coordination than in bonding configurations of the bulk. In bulk β -Ga₂O₃, oxygen atoms are either threefold or fourfold coordinated. However, the O atom admits flexible bonding patterns as it can transfer nonbonded electrons to lone pair states. It is interesting to note that each Ga layer parallel to the $(\bar{2}01)$ plane can only contain either fourfold or sixfold coordinated Ga atoms and these two types of Ga layers alternate along the direction perpendicular to the $(\bar{2}01)$ plane. In the interface model, a thick vacuum layer (~ 20 Å) is added to minimize image interactions due to the periodic boundary condition in the z direction.

We stress that our interface model satisfies the electron counting rule.^{24,45–47} In this interface model, each cation layer in β -Ga₂O₃ slab contains 12 Ga³⁺ ions, while each anion layer contains 18 O²⁻ ions. We create two O vacancies at the interface where sixteen III-O bonds are formed and each surface group-III atom forms one III-O bond. The Ga atoms in the subsurface Ga layer of the oxide are all fourfold coordinated. The dangling bonds of the surface Ga atoms caused by the O vacancies are saturated by adjacent O atoms. Therefore no dangling bonds are

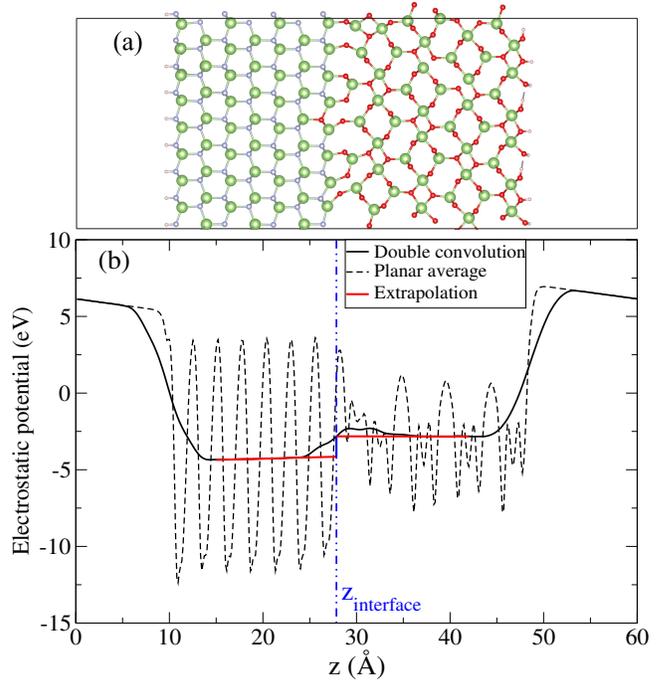


FIG. 2. (a) Atomistic model of the relaxed β -Ga₂O₃/GaN interface obtained at the PBE level and (b) its planar and macroscopically averaged electrostatic potential obtained at the PBE0(α) level. The interface lineup is determined to be 1.33 eV.

present at the interface. The interfacial O layer has 16 O²⁻ ions, contributing with -32 charges. For this interfacial O layer, the subsurface Ga layer gives $+18$ charges and the surface III layer gives $+12$ charges, adding up to $+30$ charges. To provide the additional $+2$ charges, we replace two subsurface N sites by two substitutional O_N. In this way, the interface is charge neutral (insulating) and the electron counting rule is satisfied. Hydrogen atoms are used to passivate the bottom N layer and top O layer, so that the two surfaces are insulating without any gap states. After carrying out full structural relaxations of the atomic positions in the interface models, we use the procedures described above to determine the interface lineups. Our model interfaces with the extrapolated electric fields are illustrated in Figs. 1 and 2. The calculated potential lineups at the β -Ga₂O₃/AlN and β -Ga₂O₃/GaN interfaces are 1.29 and 1.33 eV, respectively.

In order to account for the effect of strain on β -Ga₂O₃, we determine the equilibrium lattice parameters of β -Ga₂O₃ with the in-plane lattice constants controlled by the substrate and evaluate the corresponding band gaps and VBM levels. To expose the $(\bar{2}01)$ surface of β -Ga₂O₃ as in the interface models, we transform the conventional unit cell into a larger monoclinic one in which the first lattice vector \mathbf{a}' of the unit cell is transformed to $\mathbf{a}+2\mathbf{c}$, while the other two remain the same and β' is the angle between \mathbf{a}' and \mathbf{c} . This larger unit cell is strained to have the in-plane lattice constants (a' and b) determined by the AlN or GaN substrates and the other lattice pa-

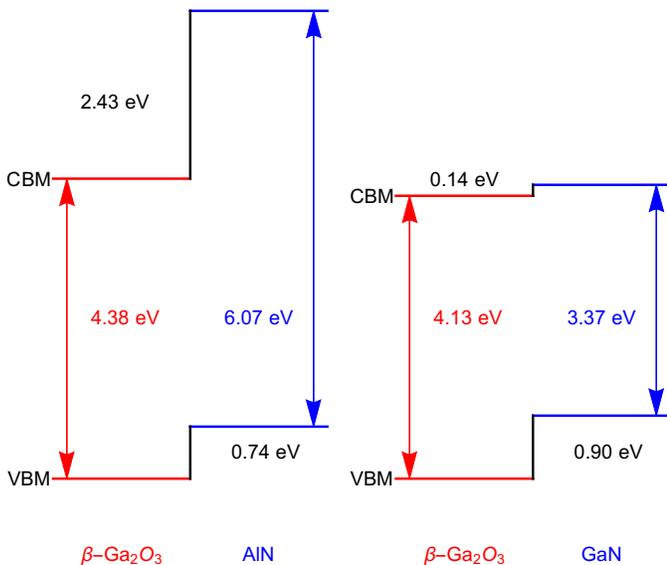


FIG. 3. The band alignment diagrams of the $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ heterojunctions.

rameters (c and β') as well as the atomic positions are optimized. The calculated band gaps and VBM levels of $\beta\text{-Ga}_2\text{O}_3$ subject to different substrates are given in Table II. We use the same exchange mixing parameter $\alpha = 0.27$ as for the unstrained bulk. Here, we assume that the electrostatic potential levels of the strained orthorhombic $\beta\text{-Ga}_2\text{O}_3$ ($\bar{2}01$) slab in the interface model and of strained monoclinic $\beta\text{-Ga}_2\text{O}_3$ are the same. We validate this assumption by comparing the average electrostatic potential levels with respect to the vacuum level in strained orthorhombic and monoclinic $\beta\text{-Ga}_2\text{O}_3$ ($\bar{2}01$) slabs. Taking structures corresponding to the AlN substrate as an example, we obtained a difference of only 0.03 eV, which negligibly affects the alignment.

The calculated band offsets at the $\beta\text{-Ga}_2\text{O}_3/\text{III-N}$ interfaces and the comparison with the available experimental results are given in Table III. In Fig. 3, we schematically show the calculated band offsets. $\beta\text{-Ga}_2\text{O}_3$ forms type II heterojunctions with both AlN and GaN.

For $\beta\text{-Ga}_2\text{O}_3$ grown on an AlN substrate, the calculated VBO of 0.74 eV is in good agreement with the value of 0.55 eV reported by Sun *et al.*⁹ We suggest that this good agreement stems from the fact that the same epitaxial relationships are used in the model and in the experiment. This minimizes defect generation at the interface and the measured offset thus remains close to its intrinsic value, which corresponds to the target of our calculations.

Additionally, to compare with the recent experimental data of Chen *et al.*,¹⁰ we also consider AlN grown on a $\beta\text{-Ga}_2\text{O}_3$ substrate. In this case, we obtain a VBO of 0.56 eV and a CBO of 1.90 eV. Hence, the VBO is found to decrease by 0.18 eV with respect to the case of $\beta\text{-Ga}_2\text{O}_3$ grown on an AlN substrate (cf. Table III). The major part (0.10 eV) of this decrease results from

TABLE III. Calculated band alignment at $\beta\text{-Ga}_2\text{O}_3/\text{III-N}$ interfaces and comparison with available experimental results. Energies are given in units of eV.

interface	VBO	CBO	Ref.	substrate
$\beta\text{-Ga}_2\text{O}_3/\text{AlN}$	0.74	2.43	Present	AlN
	0.55		Ref. 9	AlN
$\beta\text{-Ga}_2\text{O}_3/\text{GaN}$	0.56	1.90	Present	$\beta\text{-Ga}_2\text{O}_3$
	0.09		Ref. 10	$\beta\text{-Ga}_2\text{O}_3$
	-0.72		Ref. 10	$\beta\text{-Ga}_2\text{O}_3$
$\beta\text{-Ga}_2\text{O}_3/\text{AlN}$	0.90	0.14	Present	GaN
	0.78		Ref. 12	GaN
	1.40		Ref. 11	GaN

the shifts of the bulk bands in response to strain (deformation potential theory), as we checked by obtaining the VBM levels in unstrained and strained bulk materials with respect to the vacuum level. However, despite the use of the same strain conditions as in the experiment, our calculated VBO of 0.56 eV differs noticeably from the measured values of 0.09 and -0.72 eV, which refer to two different preparation methods.¹⁰ Since the difference largely exceeds the accuracy of ~ 0.2 eV expected from this type of hybrid functional calculations,¹⁷⁻²⁰ we conclude that the observed discrepancies do not depend on strain but rather arise from the departure from the nearly abrupt epitaxial interface modeled in our set-up.

For $\beta\text{-Ga}_2\text{O}_3$ grown on a GaN substrate, the calculated VBO of 0.90 eV falls well within the experimental range 0.78-1.40 eV. The experimental results are obtained through X-ray photoemission spectroscopy (XPS) and thus might suffer from inaccuracies due to the averaging over a spatial layer subject to built-in electric fields. The difference in VBOs between $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ is consistent with the trend in the electron affinities of AlN and GaN.^{48,49}

In conclusion, we studied the band offsets and the chemical bonding at $\beta\text{-Ga}_2\text{O}_3/\text{AlN}$ and $\beta\text{-Ga}_2\text{O}_3/\text{GaN}$ interfaces through advanced electronic-structure calculations. The obtained band offsets are consistent with the experimental values and provide accurate estimates for the intrinsic values pertaining to nearly abrupt epitaxial interfaces. The present study introduces modeling procedures that can straightforwardly be applied to $\beta\text{-Ga}_2\text{O}_3/\text{Al}_x\text{Ga}_{1-x}\text{N}$ interfaces, which are considered in UV detectors or light emitting diodes.⁹ More generally, this study shows how to deal with band alignments involving the ($\bar{2}01$) interface of $\beta\text{-Ga}_2\text{O}_3$. These band alignments are important for the design of devices based on $\beta\text{-Ga}_2\text{O}_3$.

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DATA AVAILABILITY

The data that support the findings of this study are freely available on the Materials Cloud platform at <https://doi.org/10.24435/materialscloud:g5-9z>, Ref. 50.

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